



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829  
Examiner: J. Hollington

4-26  
1210  
4-17-03  
J. Hollington

In Re NEW PATENT APPLICATION Of:

Applicant: Mikio OHTAKI )  
Appln. No.: 09/904,663 )  
Filed: July 16, 2001 )  
For: METHOD FOR MANUFACTURING )  
AND BATCH TESTING )  
SEMICONDUCTOR DEVICES )  
(As Amended) )  
Atty Ref.: KAN 120D1 )

**AMENDMENT  
AFTER FINAL**

April 10, 2003

Commissioner for Patents  
Washington, D.C. 20231  
**BOX - AF**

Sir:

Responsive to the Examiner's Action dated December 10, 2002, a Petition  
for a One-Month Extension of Time being submitted herewith, please amend the  
application as follows:

**IN THE SPECIFICATION**

Please replace the title on page 1 of the Specification with the following:

--METHOD FOR MANUFACTURING AND BATCH TESTING

SEMICONDUCTOR DEVICES --

FEE ENCLOSED \$ 110.  
Please charge any further  
fee to our Deposit Account  
No. 10-0002

RECEIVED  
MAY 10 2003  
TECHNICAL SERVICES  
800

O.K. x0  
enter J. H.